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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Taku HIRAYAMA et al.

Serial No. 10/568,951

Filed February 22, 2006



Mail Stop: PCT Branch

Attorney Docket No. 2006\_0227A

MATERIAL FOR FORMING RESIST PROTECTIVE FILM FOR LIQUID IMMERSION LITHOGRAPHY PROCESS, RESIST PROTECTIVE FILM FORMED BY THE MATERIAL, AND METHOD OF FORMING RESIST PATTERNS USING THE MATERIAL

### REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Enclosed herewith is a copy of the Official Filing Receipt for the above-identified application marked with an arrow indicating corrections to be made thereto.

Accordingly, it is requested that the PTO issue a Corrected Filing Receipt reflecting these corrections.

Respectfully submitted,

Taku HIRAYAMA et al.

By

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### United States Patent and Trademark Office

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**FILING OR 371** APPL NO. **ART UNIT** FIL FEE REC'D (c) DATE ATTY.DOCKET NO DRAWINGS TOT CLMS IND CLMS 10/568.951 05/05/2006 2851 1030 2006-0227A **CONFIRMATION NO. 9336** 513 WENDEROTH, LIND & PONACK, L.L.P. **FILING RECEIPT** AUG 1 3 2007 2033 K STREET N. W. 

Date Mailed: 10/31/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

#### Applicant(s)

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#### **Assignment For Published Patent Application**

TOKO OHKA KOGYO CO., LTD., Kanagawa, JAPAN

Power of Attorney: The patent practitioners associated with Customer N umber <u>513</u>.

#### Domestic Priority data as claimed by applicant

This application is a 371 of POT/JP04/12204 08/25/200

#### Foreign Applications

JAPAN 2003-300666 08/25/2003 JAPAN 2003-356963 10/16/2003

If Required, Foreign Filing License Granted: 10/2

The country code and number of your priority appli filing abroad under the Paris Convention, is **US10/568,951** 

Projected Publication Date: 02/08/2007

BroTectin

Non-Publication Request: No

**Early Publication Request: No** 

Title

Material for forming resist-protecting film for immersion exposure process, resist-protecting film made of such material, and method for forming resist pattern using such resist-protecting film

**Preliminary Class** 

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